

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	) Confirmation No. 9428
Shunpei YAMAZAKI et al.	) Group Art Unit: 2822
Application No. 10/678,139	) Examiner: Mary A. Wilczewski
Filed: October 6, 2003	)
For: METHOD FOR FABRICATING SEMICONDUCTOR THIN FILM	) Date: <u>October 26, 2009</u>

**RESPONSE TO NON-FINAL OFFICE ACTION**

**Mail Stop: AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed May 26, 2009, reconsideration and allowance of the above-referenced application are hereby requested in view of the following. A petition for a two-month extension of time as set forth under 37 C.F.R. § 1.136(a), along with the fee required by 37 C.F.R. § 1.17(a), is being submitted concurrently herewith, extending the due date for reply to October 26, 2009.